

Application No. 10/799,073

NMTI 1002-26

CERTIFICATE OF TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office at Fax No. (571) 273-8300 on 4 April 2006.

Amy Jonsson
Amy Jonsson

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Inventor:

Michel Luc Cote et al.

Application No. **10/799,073**

Confirmation No.: **8538**

Filed: **12 March 2004**

Title: **Design and Layout of Phase Shifting Photolithographic Masks**

Group Art Unit: 1756

Examiner: Stephen B. Rosasco

CUSTOMER NO. 30437

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APR 04 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.56

Sir:

It is requested that the information identified in this statement be considered by the Examiner and made of record in the above-identified application. This statement is not intended to represent that a search has been made or that the information cited in the statement is, or is considered to be, material to patentability as defined in 37 C.F.R. 1.56.

Enclosed with this statement is a Form PTO/SB/08A. The Examiner is requested to initial the form and return it to the undersigned in accordance with M.P.E.P. 609.

Also enclosed is a copy of an International Preliminary Examination Report mailed 6 February 2006 for a corresponding PCT Application.

Also enclosed with this statement is a copy of each cited document as required by 37 C.F.R. 1.98. The exception to this, in accordance with the 05 August 2003 Official Gazette Notice in which the USPTO waives the requirement for submitting copies of U.S. Patent and Publications for cases filed after 30 June 2003, is that copies of U.S. Patent documents and copies of U.S. Patent publications are not being submitted.

This statement should be considered under 37 C.F.R. 1.97(b) because it is being filed before the mailing date of the first Office Action on the merits.

Fee Authorization. The Commissioner is hereby authorized to charge underpayment of any additional fees or credit any overpayment associated with this communication to Deposit Account No. 50-0869 (NMTI 1002-26). A duplicate copy of this authorization is enclosed.

Respectfully submitted,

Date: 4/4/06

By: 

Kenta Sazue Reg. No. 45,145

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**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Substitute for form PTO-1449

Sheet 1 of 1

Application Number	10/799,073
Filing Date	12 March 2004
First Named Inventor	Michel Luc Cote
Art Unit	1756
Examiner Name	Stephen B. Rosasco
Attorney Docket Number	NMTI 1002-26

U.S. PATENT DOCUMENTS

Examiner's Initials		Patent No. Number-Kind Code	Pub. Date MM-DD- YYYY	Name	Pages, Cols, Lines of Relevant Passages or Figures
	A1	US 6,040,892	03-21-2000	Pierrat	
	A2	US			
	A3	US			
	A4	US			
	A5	US			
	A6	US			

FOREIGN PATENT DOCUMENTS

Examiner's Initials		Patent No. Number-Kind Code	Pub. Date MM-DD-YYYY	Name	Pages, Cols, Lines of Relevant Material	T
	B1					
	B2					
	B3					
	B4					
	B5					
	B6					

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner's Initials		Include name of the author (in CAPITAL LETTERS), title of article, title of item (book, magazine, journal, serial, symposium, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T
	C1	Jinbo et al. "0.2um Or Less i-Line Lithography By Phase-Shifting Mask Technology" IEEE, pp. 33.3.1-33.3.4 (1990).	
	C2		
	C3		
	C4		

Examiner
SignatureDate
Considered